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CCEPTED MANUSCRIPT

Amorphous Silicon Nanotubes via Galvanic

Displacement Deposition

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**Abstract** 

Amorphous silicon nanotubes were grown in a single step into a polycarbonate membrane by

a galvanic displacement reaction conducted in aqueous solution. In order to optimize the process, a

specifically designed galvanic cell was used. SEM images, after polycarbonate dissolution, showed

interconnected nanotube bundles with an average length of 18 µm and wall thickness of 38 nm.

The deposited silicon was revealed by EDS analysis, whilst X-ray diffraction and Raman

spectroscopy showed that nanotubes have an amorphous structure. Silicon nanotubes were also

characterized by photo-electrochemical measurements that showed n-type conductivity and optical

gap of ~1.6 eV.

Keywords: Silicon nanotubes; Galvanic displacement deposition; Template synthesis; Li-ion

batteries; Solar cells; Amorphous silicon.

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